

07/26/01
JC992 U.S. PTO

EXPRESS MAIL NO. EL846074315US

7-27-01
A
Docket No. 57A 3127
Date: July 26, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assistant Commissioner for Patents
Washington, D.C. 20231jc971 U.S. PTO
09/915618
07/26/01

Dear Sir:

Transmitted herewith for filing is the patent application for inventor(s):

YOSHIKAZU NAKAYAMA and AKIO HARADA

For: LITHOGRAPHIC METHOD USING ULTRA-FINE PROBE NEEDLE

Also enclosed are:

11 sheets of drawings

Certified copy of Japanese Patent Application No. _____ of _____ on which Convention priority is claimed

Declaration and Power of Attorney

Information Disclosure Statement by Applicant

Preliminary Amendment

An assignment of the invention to YOSHIKAZU NAKAYAMA and DAIKEN CHEMICAL CO., LTD.

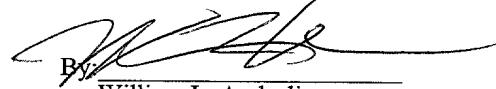
Applicant claims Small Entity Status

CALCULATION OF FEES						
ITEM		TOTAL NO. OF CLAIMS		NO. OF CLAIMS OVER BASE	LG/SM \$ ENTITY FEE	\$ AMOUNT
A	TOTAL CLAIMS FEE	11	-20	0	LG=\$18 SM=\$9	\$ 0
B	INDEPENDENT CLAIMS FEE*	1	-3	0	LG=\$80 SM=\$40	\$ 0
C	SUBTOTAL - ADDITIONAL CLAIMS FEE (ADD FINAL COLUMN IN LINES A + B)					
D	MULTIPLE-DEPENDENT CLAIMS FEE					
	LARGE ENTITY FEE = \$270 SMALL ENTITY FEE = \$135					
E	BASIC FEE					
	LARGE ENTITY FEE = \$710 SMALL ENTITY FEE = \$355					
F	TOTAL FILING FEE (ADD TOTALS FOR LINES C, D, AND E)					
G	ASSIGNMENT RECORDING FEE					
	\$ 40					
	*LIST INDEPENDENT CLAIMS 1					

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Account No. 11-1445. A duplicate copy of this sheet is enclosed.

A check in the amount of \$ 490 to cover the filing fee is enclosed.

A check in the amount of \$ 40 to cover Assignment Recordation fee is enclosed.

Respectfully submitted,
KODA & ANDROLIA
By
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I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail No. EL846074315US addressed to:

Assistant Commissioner for Patents
Washington, D.C. 20231

on July 26, 2001 by Inja Yi.

Dated: 7/26/01

By: Inja Yi

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MIKI

Inventor(s):

YOSHIKAZU NAKAYAMA and AKIO HARADA

For:

LITHOGRAPHIC METHOD USING ULTRA-FINE PROBE NEEDLE